



IFed

In re application of : Attorney Docket No. 2005\_1690A  
Masahiro GOTO et al. : **Confirmation No. 2837**  
Serial No. 10/554,204 : Group Art Unit 1794  
Filed December 13, 2005 : Examiner Timothy M. Speer  
COPPER OXIDE THIN FILM LOW- : **Mail Stop: ISSUE FEE**  
FRICTION MATERIAL AND FILM-  
FORMING METHOD THEREFOR

### SUPPLEMENTAL RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Referring to the Response filed December 9, 2009, Applicants have submitted a verified English translation of the Japanese priority application (2003-120461) corresponding to the present U.S. application. The CERTIFICATE attached to the translation refers to this priority application as well as another application (2003-017866). To clarify the record, Applicants note that the previously submitted translation of the Japanese priority application is only for the 2003-120461 application. A substitute, executed CERTIFICATE page to reflect this is enclosed.

Respectfully submitted,

Masahiro GOTO et al.

By Michael R. Davis  
Michael R. Davis  
Registration No. 25,134  
Attorney for Applicants

MRD/pth  
Washington, D.C. 20005-1503  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
January 25, 2010